

INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
49657-551

SERIAL NO.

APPLICANT
Kazuhiro AIHARA, et al.

FILING DATE
February 07, 2000

GROUP

JCS64 U.S. PTO
 09/499037
 02/07/00

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
<i>HPu</i>	9-246494	Sept. 19, 1997	JAPAN (with English abstract)				
<i>HPu</i>	8-293494	Nov. 5, 1996	JAPAN (with English abstract)				

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>HPu</i>	"Optimum Electrode Materials for Ta ₂ O ₅ Capacitors for High- and Low-Temperature Processes", H. Matsushashi et al., Jpn. J. Appl. Phys., Vol. 33 (1994), pp. 1293-1297

EXAMINER <i>J. Mondt</i>	DATE CONSIDERED <i>Aug. 20 '01.</i>
-----------------------------	--

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.